



APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	APERTURE PLATE FOR OPTICAL LITHOGRAPHY SYSTEMS		
Application Type : regular, utility Attorney Docket Number : NTCP0035USA			
Correspondence address: Customer Number: 027765 			
Inventor Information: <u>Inventor 1:</u> Applicant Authority Type: Inventor Citizenship: TW Given Name: Yuan-Hsun Family Name: WU Residence: City of Residence: Tao-Yuan Hsien Country of Residence: TW Address-1 of Mailing Address: Pu-Ren No. 66-88, Community 5, Pu-Ching Li, Address-2 of Mailing Address: Chung-Li City of Mailing Address: Tao-Yuan Hsien State of Mailing Address: Postal Code of Mailing Address: Country of Mailing Address: TW Phone: Fax: E-mail:			
Attorney Information: practitioner(s) at Customer Number: 027765  as my attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.			